


<b>Search Notes</b>  	<b>Application/Control No.</b>  10578029	<b>Applicant(s)/Patent Under Reexamination</b>  KIM ET AL.
	<b>Examiner</b>  PAISLEY L ARENDT	<b>Art Unit</b>  2881

SEARCHED			
Class	Subclass	Date	Examiner
349	49-53 (Limited Search)	3/3/2008	PLA

SEARCH NOTES		
Search Notes	Date	Examiner
See attached Search History.	3/3/2008	PLA

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner